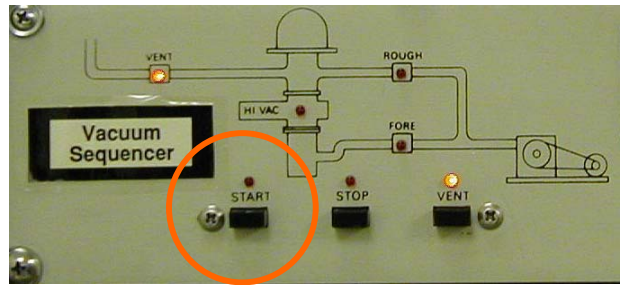
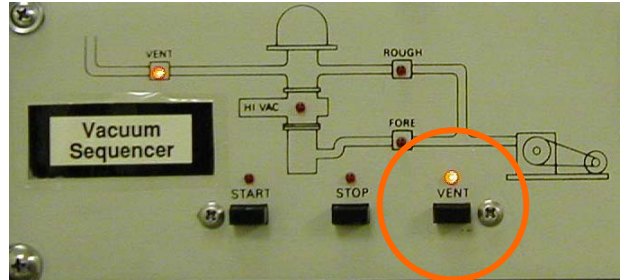


OPERATING PROCEDURE CVC 601 Unloading the Substrates

Rev. 12/5/2001

Vent

1. Turn **OFF** the **water recirculator** under table.
2. Press **VENT** on the Automatic Valve Control.
3. After system reaches atmosphere, the green vacuum LED on the interlock control panel will extinguish. Raise the chamber cover with the switch on the vacuum chamber.
4. Unload substrates
5. Lower chamber cover.
6. Press **START** on the Automatic Valve Control.
7. Check on the **Throttle Valve** switch + round knob next to switch is **OPEN**.
8. Ensure that the system goes into high vacuum and reaches a low base pressure ($< .01$ on the TC gauge).



Post Run

1. **DO NOT** turn off the Argon cylinder in the last chase.
2. **Remember to record your deposition in the logbook.**
3. Place all targets and materials in the dry box.

